

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Koga

Application No.: 09/885,362

Filed: 06/20/2001

Title: Automated Semiconductor Probing Device

Attorney Docket No.: CORE-69 120-322

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Group Art Unit: 2829

Examiner: Chan

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RESPONSE UNDER 37 CFR 1.111

Dear Sir:

In response to the Office Action of August 8, 2003, please amend this application as shown in the sheets attached hereto.

REMARKS

Reconsideration and further examination is respectfully requested.

Rejections under 35 U.S.C. §112, second paragraph:

Claims 3-4 and 35-39 were rejected under 35 U.S.C. §112, second paragraph as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

Applicants have amended the claims to overcome this ground of rejection. For example, claim 3 has been amended to recite "...comprising said probe assembly being selectively movable toward said semiconductor support fixture along a line, and said semiconductor support fixture being selectively movable toward the probe assembly along the line, wherein the line